



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 16, 2026

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

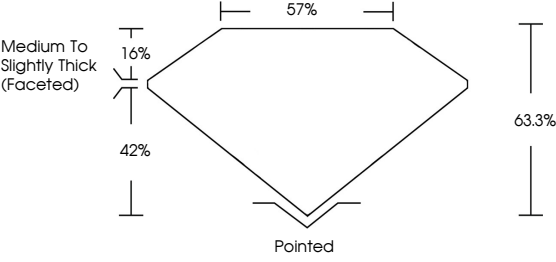
INSCRIPTION(S)

COMMENTS: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

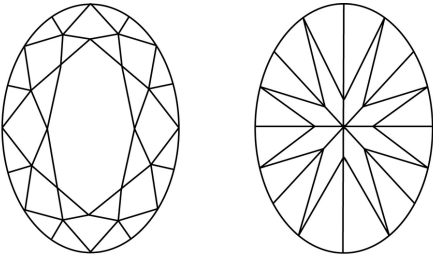
LG811645660

Report verification at [igi.org](#)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY

D	E	F	G	H	I	J	Faint	Very Light	Light
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³				
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included				

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IGI

2.03 CARATS

D

FLAWLESS

EXCELLENT

EXCELLENT

NONE

IGI LG811645660

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July 16, 2026	IGI Report No LG811645660	OVAL BRILLIANT	2.03 CARATS	D	FLAWLESS	63.3%	57%	Medium to Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG811645660
Carat Weight	Color Grade	Clarity Grade	Table	Depth	Girdle	Culet	Polish	Symmetry	Fluorescence	Inscription(s)	Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa		